	Application No.	Applicant(s)	
AL 41 PAU 1114	10/806,520	CHERUKURI ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Thinh T. Nguyen	2818	
The MAILING DATE of this communication ap All claims being allowable, PROSECUTION ON THE MERITS I herewith (or previously mailed), a Notice of Allowance (PTOL-8 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT of the Office or upon petition by the applicant. See 37 CFR 1.3	IS (OR REMAINS) CLOSED in IS) or other appropriate commu RIGHTS. This application is s	this application. If not included nication will be mailed in due course. THIS	ve
1. This communication is responsive to 2/23/06.			
2. X The allowed claim(s) is/are 1-9,11,19 and 20.			
3. ☐ Acknowledgment is made of a claim for foreign prioritya) ☐ All b) ☐ Some* c) ☐ None of the:	under 35 U.S.C. § 119(a)-(d) o	or (f).	
Certified copies of the priority documents ha			
2. Certified copies of the priority documents ha	- · ·		
3. Copies of the certified copies of the priority of	documents have been received	I in this national stage application from the	
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requirements	
4. A SUBSTITUTE OATH OR DECLARATION must be sub INFORMAL PATENT APPLICATION (PTO-152) which g			
5. CORRECTED DRAWINGS (as "replacement sheets") m	oust be submitted.		
(a) ☐ including changes required by the Notice of Draftspe	erson's Patent Drawing Review	(PTO-948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date	<u>_</u> .		
(b) \square including changes required by the attached Examine	er's Amendment / Comment or	in the Office action of	
Paper No./Mail Date			
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in			
 DEPOSIT OF and/or INFORMATION about the department of attached Examiner's comment regarding REQUIREMEN 			
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5 🖂 Notice of Inf	ormal Patent Application (PTO-152)	
 Notice of Preferences offed (1 10-032) District Notice of Draftperson's Patent Drawing Review (PTO-948) 		Immary (PTO-413),	
•	Paper No./I	Mail Date	
 Information Disclosure Statements (PTO-1449 or PTO/SE Paper No./Mail Date 	3/08),	Amendment/Comment	
 Examiner's Comment Regarding Requirement for Deposit of Biological Material 	t 8. ⊠ Examiner's	Statement of Reasons for Allowance	
	9. 🗌 Other	•	
2	Devid Note:		
Silneri	David Nelms risory Patent Examiner		
	nsory ratent Examiner Nology Center 2800		

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DETAILED ACTION

Reason for allowance

- 1. Claims 1-9,11,19-20 are allowed. The following is an examiner's statement of reason for allowance: None of the references of record teaches or suggests the claimed -- "Vertically stacked semiconductor device "-- having the limitations:
- --" metal standoff having the same thickness as the bond pad caps disposed on the first surface, contacting the protective overcoat laver to separate the supporting chip from the next successive chip;

and a plurality of bond wires connecting at least one chip to said substrate."-And all other limitations /steps as recited in claim 1.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

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Conclusion

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2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thinh T Nguyen whose telephone number is 571-272-1790. The examiner can normally be reached on Monday-Friday 9:30am-6:30pm.If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached at 571-272-1787.

The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval [PAIR] system.

Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free)

Thinh T Nguyen

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David Nelms
Supervisory Patent Examiner
Technology Center 2800